



XA-9590
PATENT APPLICATION

Response Under 37 C.F.R. 1.116
Expedited Procedure
Examining Group 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Masao SHINOZAKI et al.

Serial No.: 10/002,009

Group Art Unit: 2814

Filed: December 5, 2001

Examiner: S. Rao

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING
A SEMICONDUCTOR DEVICE

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AMENDMENT AFTER FINAL REJECTION

BOX AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed March 4, 2003,
please amend the above-identified patent application as
indicated below.

Amendments to the claims begin on page 2 of this
paper.

Remarks/Arguments begin on page 8 of this paper.

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